

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79289

Masayuki TAKASHIMA, et al.

Appln. No.: 10/750,971

Group Art Unit: 1751

Confirmation No.: 1869

Examiner: Brian P. MRUK

Filed: January 5, 2004

For: CLEANING SOLUTION FOR SEMICONDUCTOR SUBSTRATE

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 14, 2007, please amend the above-identified application as follows on the accompanying pages.

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